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**BOX AF RESPONSE UNDER 37 C.F.R. 1.116 - EXPEDITED  
PROCEDURE - EXAMINING GROUP 2813**

Attorney Docket No. 5649-874

AF/2800

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Hag-ju Cho

Serial No.: 09/893,035

Filed: June 27, 2001

For: METHODS OF MANUFACTURING INTEGRATED CIRCUIT DEVICES  
THAT INCLUDE A METAL OXIDE LAYER DISPOSED ON ANOTHER  
LAYER TO PROTECT THE OTHER LAYER FROM DIFFUSION OF  
IMPURITIES AND INTEGRATED CIRCUIT DEVICES  
MANUFACTURED USING SAME

Group Art Unit: 2813

Examiner: Erik J. Kielin

Confirmation No.: 3421

Date: November 12, 2003

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT AFTER FINAL**

Sir:

Applicants provide the present Request For Reconsideration to address the issues raised in the Official Action mailed September 11, 2003 ("the Action").

Applicants provide the present Request For Reconsideration pursuant to the rules stated in revised 37 C.F.R. 1.121 that became effective on July 30, 2003.

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